

Honeywell's Docket No. H0004870 US -4015 Aptitioner's Docket No. H9945-1305 (7240122001-3224000)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Mize et al.

Serial No:

10/542040

Filed:

July 13, 2005

For:

Apparatus and Methods

for Ionized Deposition of a

Film or Thin Layer

Group:

Not Yet Assigned

Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

MAIL STOP DD **COMMISSIONER OF PATENTS** PO Box 1450 **ALEXANDRIA, VA 22313-1450**

Sir:

In accordance with the duty of disclosure imposed by 37 C.F.R. § 1.56 to inform the United States Patent and Trademark Office of all references coming to the attention of the Applicant(s) or attorneys or agents for Applicant(s) which are or may be material to the examination of the subject application, attorneys for the Applicant(s) hereby invite the Examiner's attention to the references listed in the accompanying PTO Form 1449 entitled "List of References Cited".

This submission is understood to complement the results of the Examiner's own independent search. The submission of this Disclosure Statement should not be construed as a representation that a search was made, or that the cited items are inclusive of all relevant and material citations that may be available publicly.

Honeywell's Docket No. H0004870 US -4015 Practitioner's Docket No. H9945-1305 (7240122001-3224000)

Applicant(s) respectfully request that the Examiner review the foregoing references, as set forth in the Form PTO-1449, and that they be made of record in the file history of the above-captioned application.

Respectfully submitted,

Buchalter Nemer, A Professional Corporation

Dated: October 13, 2005

Sandra P. Thompson Reg. No. 46,264

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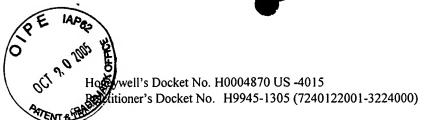
Attorneys for Applicant(s) 18400 Von Karman, Suite 800 Irvine, CA 92612

Tel: 949-224-6282 Fax: 949-720-0182

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				ATTY. DOCKET NO.		SERIAL NO.			
	LIST OF REFERENCES CITED BY APPLICANT APPLICANT APPLICANT					10/542040			
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U.S. PATEN	IT DOCUMENTS								
*EXAMINER INITIAL	· DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILIN	G DATE ROPRIATE	
	US 2001/0007302	07/12/01	Hong		204	192.12	05/16/97		
	US 2001/0019016	09/06/01	Subramani et al.		204	192.1	04/10/01		
	US 2002/0047116	04/25/02	Pavate et al.		257	44	09/28/01		
	US 2002/0144901	10/10/02	Nulman et al.		204	298.06	01/17/02		
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	DOCUMENT NUMBER	DATE	COUNTRY		CLASS	SUBCLASS	TRANSLATION		
	DOCOMENT NOMBER	DATE		COUNTRY	CLASS	SUBCLASS	YES	NO	
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)									
•	PCT International Search F	PCT International Search Report dated October 26, 2004							
-	PCT Written Opinion dated	PCT Written Opinion dated October 26, 2004							
	PCT International Prelimina	PCT International Preliminary Examination Report dated August 4, 2005							
EXAMINER DATE CONSIDERED									

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



PATENT

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Mail Stop DD Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT WITHIN THREE MONTHS OF FILING OR BEFORE MAILING OF FIRST OFFICE ACTION (37 C.F.R. 1.97(b))

IDENTIFICATION OF TIME OF FILING THE ACCOMPANYING INFORMATION DISCLOSURE STATEMENT

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of a first Office action on the merits, whichever event occurs last. 37 C.F.R. 1.97(b).

Date: October 13, 2005

Sandra P. Thompson

pectfully submitte

Reg. No. 46264

Attorneys for Applicant Buchalter Nemer, A Professional Corporation 18400 Von Karman, Suite 800 Irvine, CA 92612

Tel: (949) 224-6282

CERTIFICATE OF MAILING (37 C.F.R. 1.8(a))

I hereby certify that, on the date shown below, this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed to the Commissioner for Patents, PO Box 1450, Alexandria, VA

Kristin J. Azcons

Date: October 13, 2005